NO. 8176 P. 5

JUL 0 6 2006

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s):

Venkat Selvamanickam, et al.

Title:

APPARATUS FOR HIGH-THROUGHPUT ION BEAM-ASSISTED

DEPOSITION (IBAD)

App. No.:

10/602,467

Filed:

June 23, 2003

Examiner:

Brain K. Talbot

Group Art Unit:

1762

Customer No.: 34456

Confirmation No.:

2664

Atty. Dkt. No.: 1014-SP103

MS RCE

Commissioner for Patents

PO Box 1450

Alexandria, VA 22313-1450

AMENDMENT IN SUPPORT OF RCE

Dear Sir:

In response to the Final Office Action mailed January 6, 2006, please amend the aboveidentified application as follows:

CERTIFICATE OF TRANSMISSION/MAILING

I hereby certify that this correspondence is being facsimile transmitted to the USPTO or deposited with the United States Postal Service with sufficient postage as first class mail, in an cavelope addressed to the Commissioner for Patents on

Rlisc K. Dougherty Typed or Printed Name